

Semiconductor laser wish list

MTO Symposium



Dr. Henryk Temkin

San Jose, CA

March 5-7, 2007

Report Documentation Page

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Semiconductor laser wish list



Today

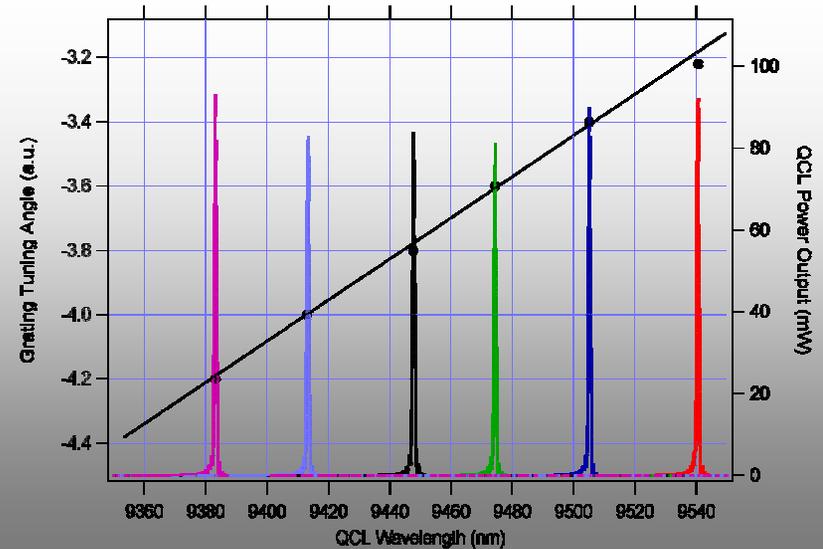
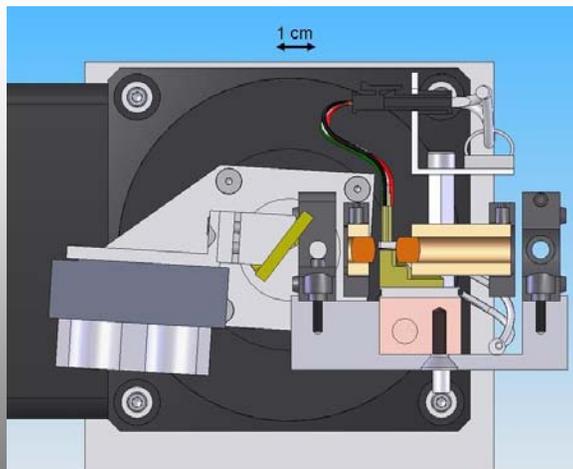
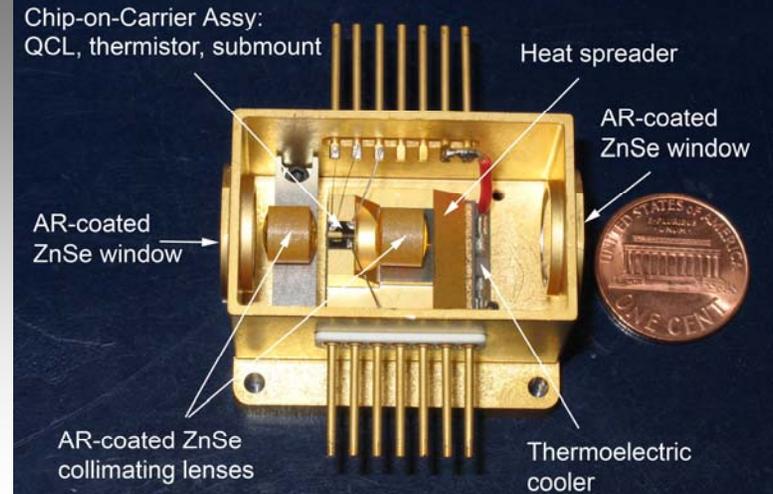
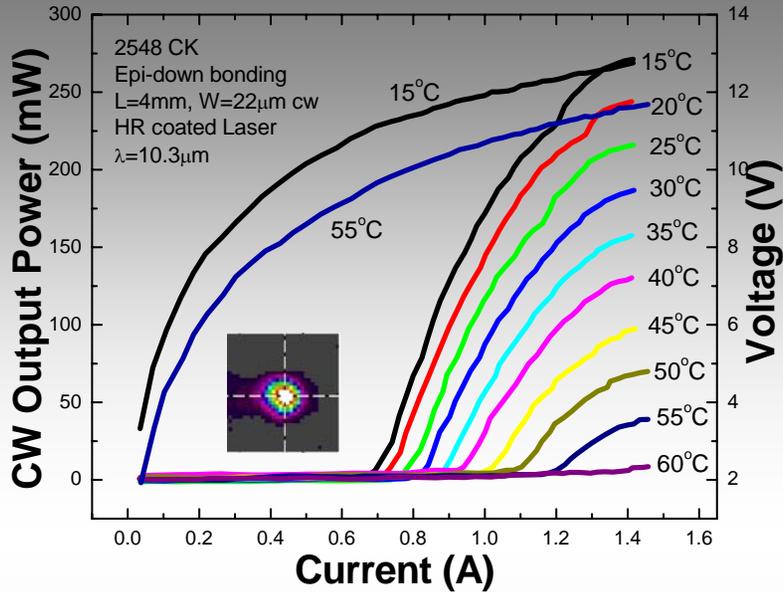
- **Wide wavelength range and tunability (L-PAS, SAIL)**
- **Efficient mid-IR operation (EMIL)**
- **Scalable Power**

Tomorrow

- **Really small lasers**
- **Really fast lasers with engineered RF response**
- **Lasers and non-linear waveguides**

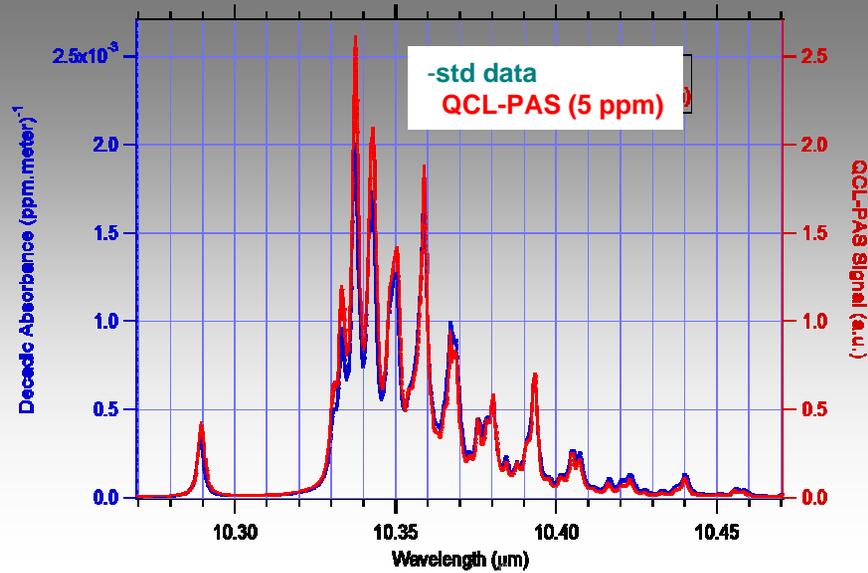


Quantum Cascade Laser

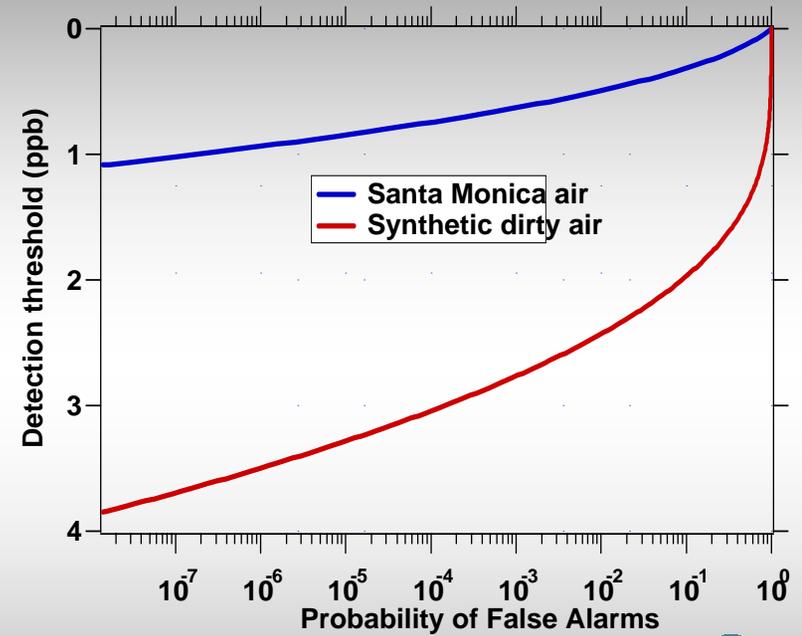




Tuning is a big deal

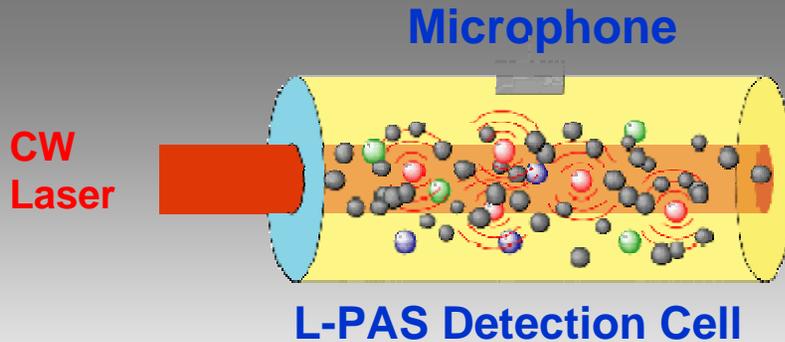


Detection in the presence of interferents





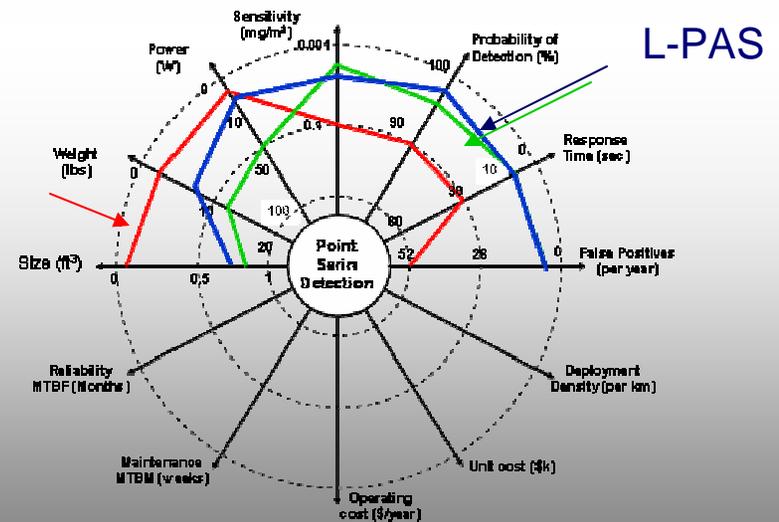
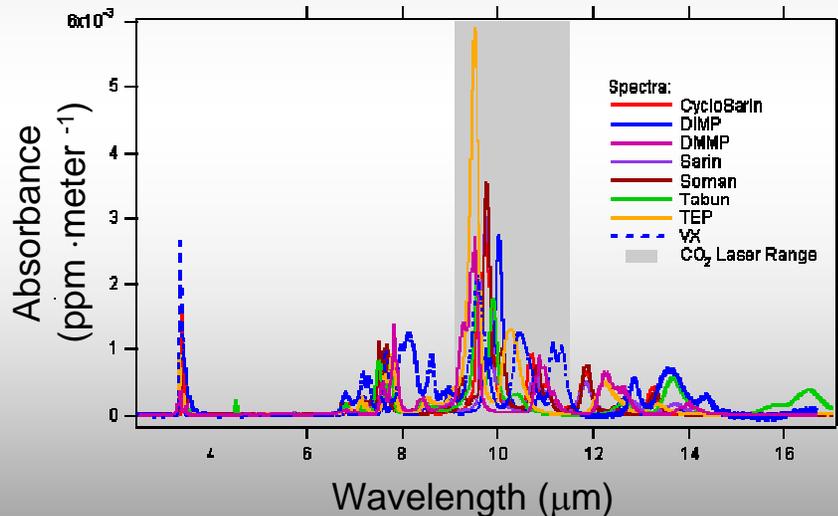
Laser Photoacoustic Spectroscopy (L-PAS)



Quantum Cascade Lasers enable development of new CWA sensors:

- Sub-ppb sensitivity (order of magnitude improvement over SOA)
- High specificity with false alarm rate reduced to $< 10^{-6}$
- Response time reduced from ~ 1 min to ~ 10 seconds

Absorption spectra of CWAs



LASER PHOTOACOUSTIC SPECTROSCOPY
LPAS



Need For IRCM



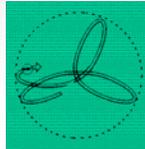
Threats Exceed
1,000,000 Missiles
World-wide



1960s
Spin Scan

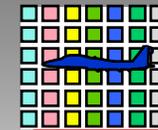
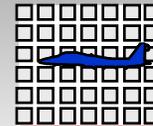
1970/80
Cooled
Con Scan

1980s/90s
Cross Array/Rosette
Flare CCMs



2000
Scanning
Imagers

2005
1st Generation
Imagers



2010
2nd Generation
Multispectral

The race continues!
NEED lasers with:
10s Watt output power
CW room temperature
High Wallplug Efficiency
Excellent beam properties



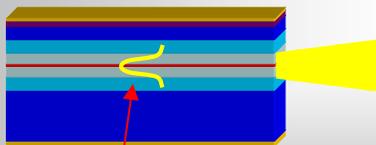


Fundamental Limits for MWIR Lasers in Wall-Plug Efficiency (WPE)

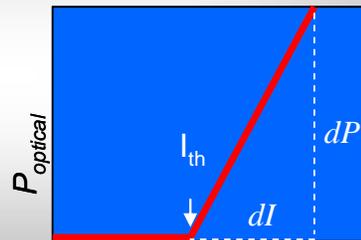


Current efficiency = η_c

$$\eta_c = \frac{I - I_{th}(T)}{I} \frac{\alpha_m}{\alpha_{tot}(T)} \quad I_{th} = \frac{1}{\tau_3(1 - \tau_2/\tau_{32})} \left[\frac{\epsilon_0 n_{eff} \lambda L_p (2\gamma_{32})}{4\pi z_{32}^2} \frac{\alpha_{tot}}{\Gamma} + qn_{2D} e^{-\Delta/k_B T} \right]$$



Waveguide loss α_w

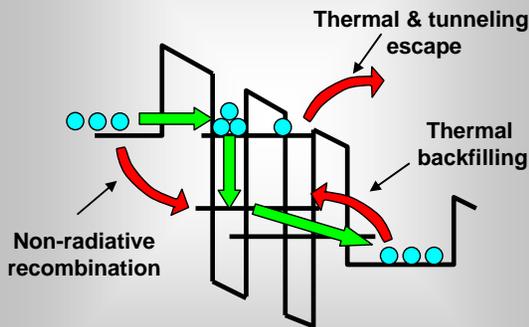


Current

$$\eta_{WPE} = \frac{P_{Optical}}{P_{Electrical}} = \eta_V \eta_C \eta_i \eta_{mo}$$

Internal efficiency = η_i

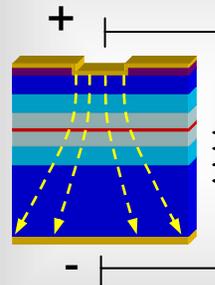
$$\eta_i = \xi \frac{\tau_{eff}}{\tau_{eff} + \tau_2}$$



$$\tau_{eff} = \tau_3 \frac{\tau_{32} - \tau_2}{\tau_{32}}$$

Voltage efficiency = η_V

$$\frac{N\hbar\omega}{N(\hbar\omega + \Delta) + qR_s I}$$

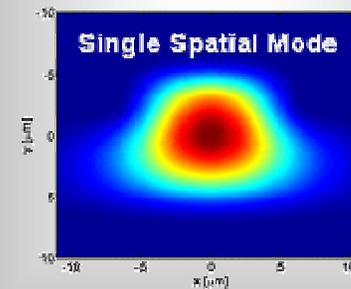


$$V = N_p (V_{act} + V_{inj}) + IR_s$$

$$\frac{\text{photon energy}}{\text{bias per stage}} = \frac{\hbar\omega}{\hbar\omega + 2\hbar\omega_{LO} + \Delta E} \rightarrow \frac{\hbar\omega}{\hbar\omega + 2\hbar\omega_{LO}}$$

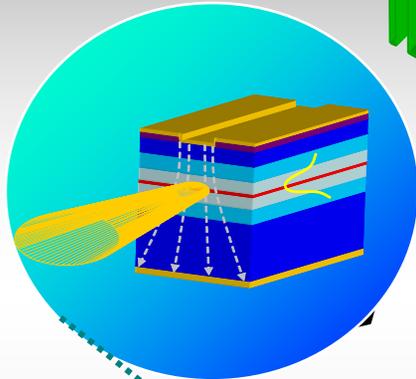
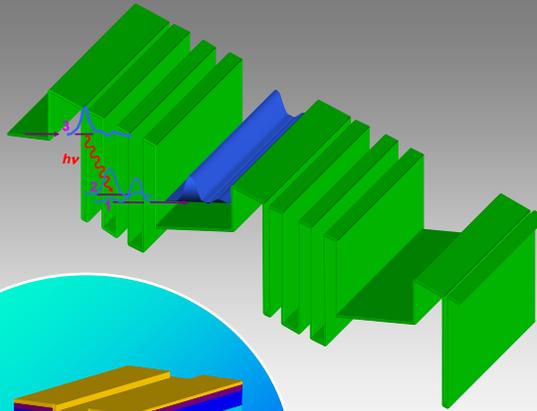
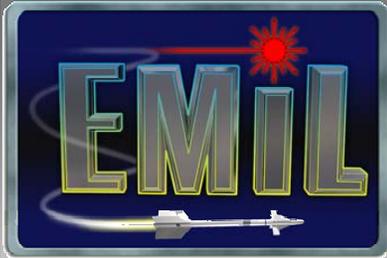
Modal efficiency = η_{mo}

$$\eta_{mo} = \frac{\sum_{i=1}^{N_p} \Gamma_i^2}{N_p \sum_{i=1}^{N_p} \Gamma_i^2}$$

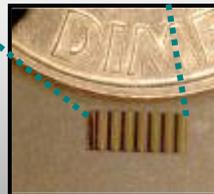




Efficient Mid-Wave Infrared Lasers (EMIL)



SOA Mid IR Optical Bench



"IRCM laser-on-a-chip"

Program Objective

- Breakthrough in wall-plug efficiency for lasers in the critical mid-wave infrared bands
 - Band IVa (3.8 – 4.2 μm)
 - Band IVb (4.5 – 4.8 μm)

DoD Benefits

- Reduce laser size/weight/power
 - Enable IRCM systems on smaller, vulnerable platforms (e.g., rotorcraft, UAVs)
- IRCM with higher modulation rates than SOA
 - Counter emerging threats (e.g., FPAs)

"2W in, 1W out!"

T. Tether
06 Jan 2006

Slide 8

MJR1

BAE LAMBS

51 optics

4 resonators

Mark J. Rosker, 11/23/2005



Raman beam combining and cleanup



1. Raman beam cleanup

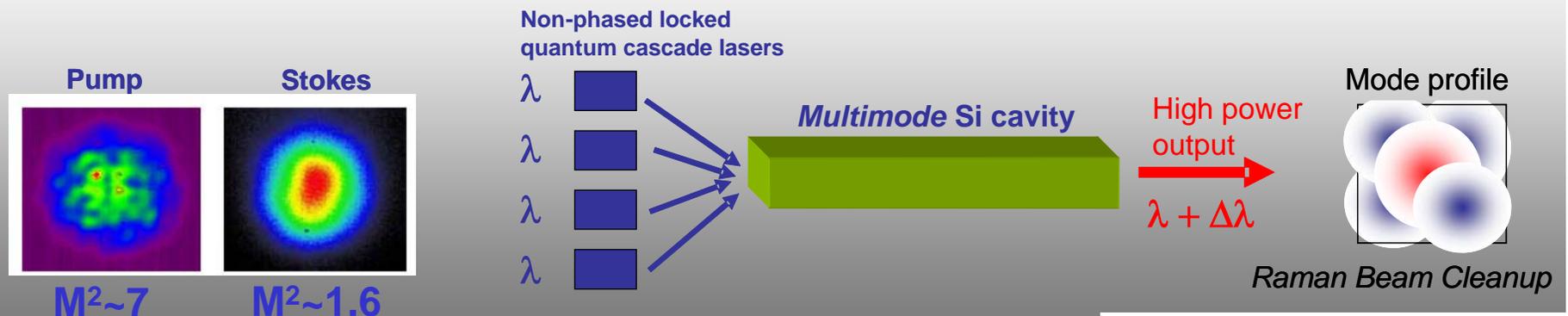
Converts a low quality pump into a diffraction limited beam

2. Combine multiple pumps via self imaging in multimode waveguide

- *Incoherent* power combining of N oscillators – phase control not necessary

3. Silicon as the active material

- High gain coefficient → compact lasers and amplifiers
- High thermal conductivity → power scaling, excellent cooling
- High optical damage threshold → high pulse energy
- Low dn/dT and elasto-optic coefficient → high beam quality

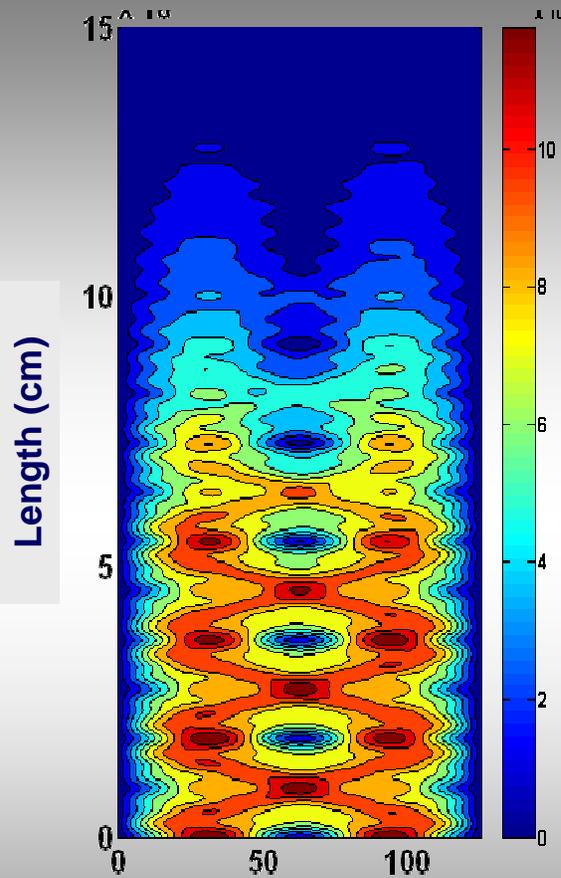




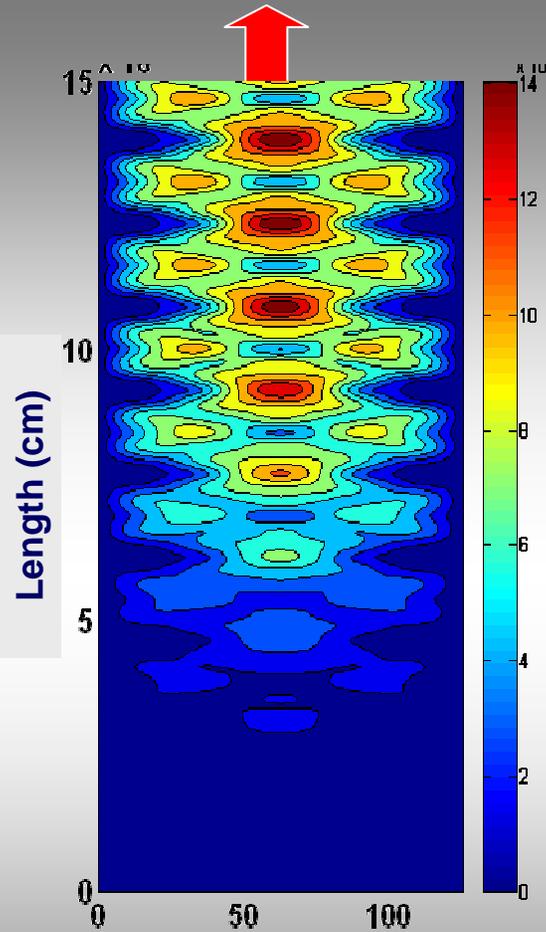
Simulation of Amplification Via Self Imaging in Multimode Si Waveguide



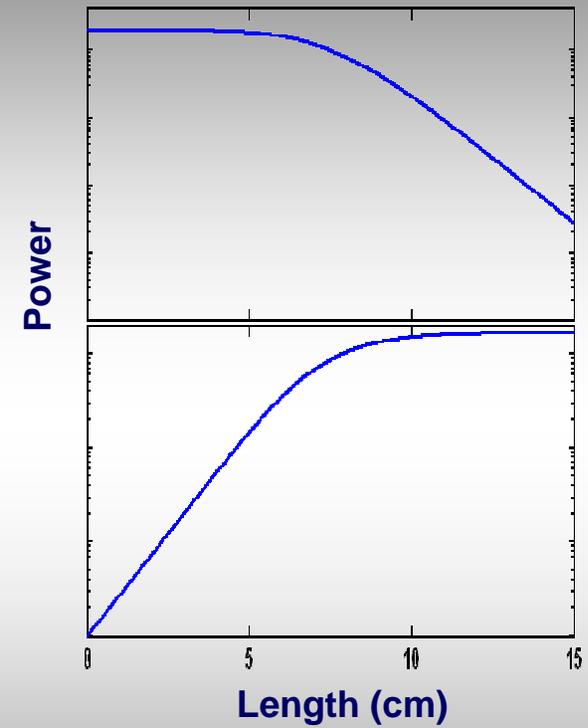
Power evolution



PUMP1 and 2 each 1KW
1kW is peak pulse power, average pump power is in milli-Watts range



1W Stokes





Si and conventional Raman crystals

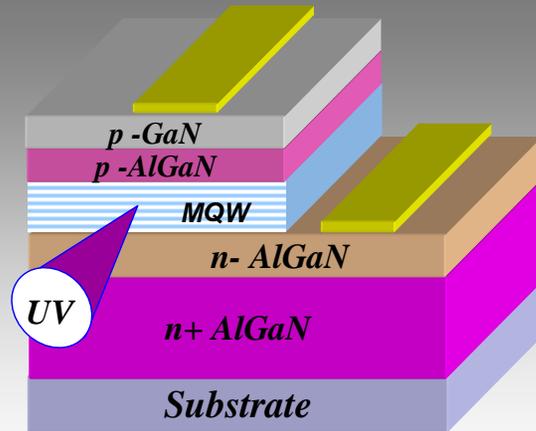


Property	Silicon	Ba(NO ₃) ₂	LiIO ₃	KGd(WO ₄) ₂	CaWO ₄
Optical damage threshold (MW/cm ²)	~1000-4000	~400	~100	-	-
Thermal conductivity (W/m-K)	148	1.17	-	2.6 [1 0 0] 3.8 [0 1 0] 3.4 [0 0 1]	16
Raman gain (cm/GW)	20 (1550nm)	11 (1064nm)	4.8 (1064nm)	3.3 (1064 nm)	-
Transmission Range (μm)	1.1-6.5	0.38-1.8	0.38-5.5	0.35-5.5	0.2-5.3
Refractive index	3.42	1.556	1.84	1.986 - 2.033	1.884
Raman shift at 300K (cm ⁻¹)	521	1047.3	770 822	901 768	910.7
Spontaneous Raman linewidth (cm ⁻¹)	3.5	0.4	5.0	5.9	4.8

- 10x higher optical damage threshold
- 100x higher thermal conductivity
- High Raman gain, excellent large crystals



Semiconductor AlGaIn Injection Lasers (SAIL)



Objective

- Develop AlGaIn injection lasers emitting in the ultraviolet; $\lambda=340-280$ nm.

Impact

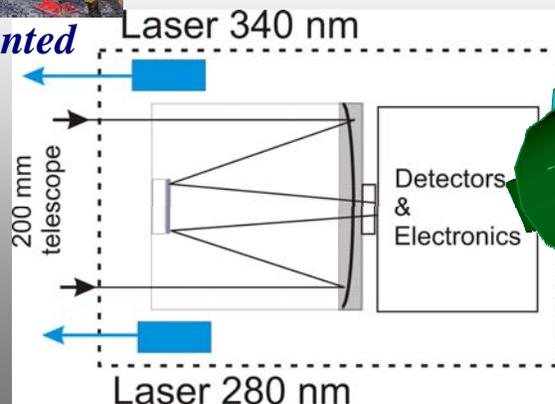
- Stand-off bio-agent detection; Bio-LIDAR



Truck mounted



Hand held



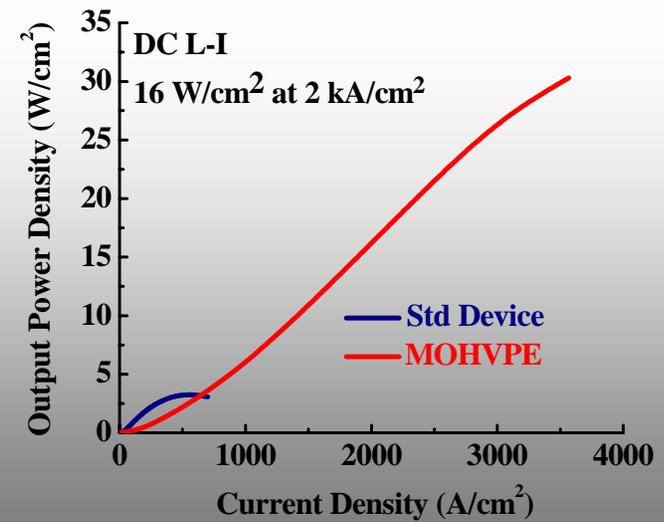
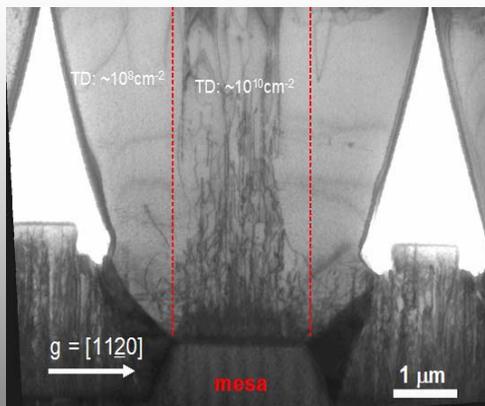
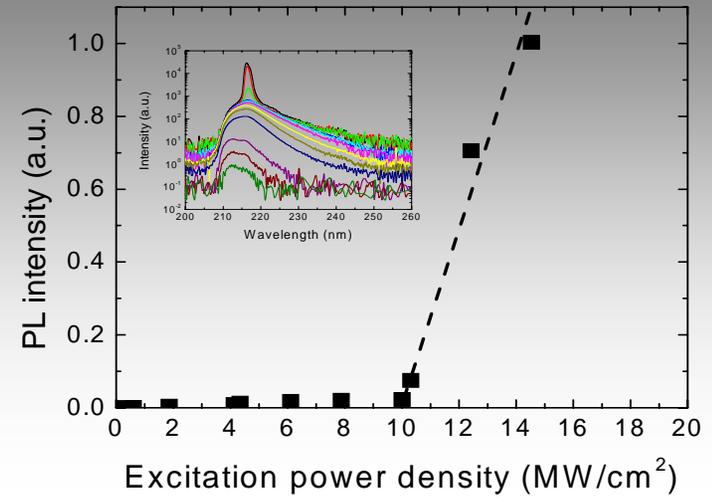
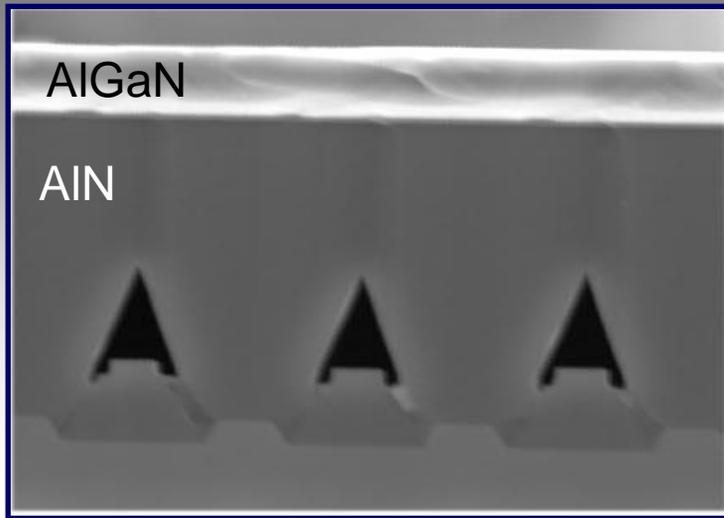
Key technical goals

- Reduce dislocation density of AlGaIn structures by three orders of magnitude, to less than $10^7/\text{cm}^2$
- Increase p-type doping in AlGaIn to support current densities of $10 \text{ kA}/\text{cm}^2$, to $1 \times 10^{18} \text{ cm}^{-3}$
- Increase luminescence efficiency of AlGaIn active layer to $IQE \sim 60\%$
- Demonstrate stable laser operation





SAIL – Pulsed Lateral Overgrowth

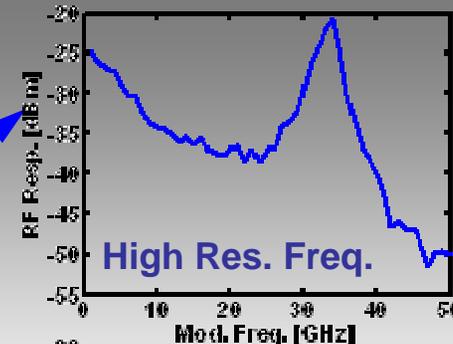
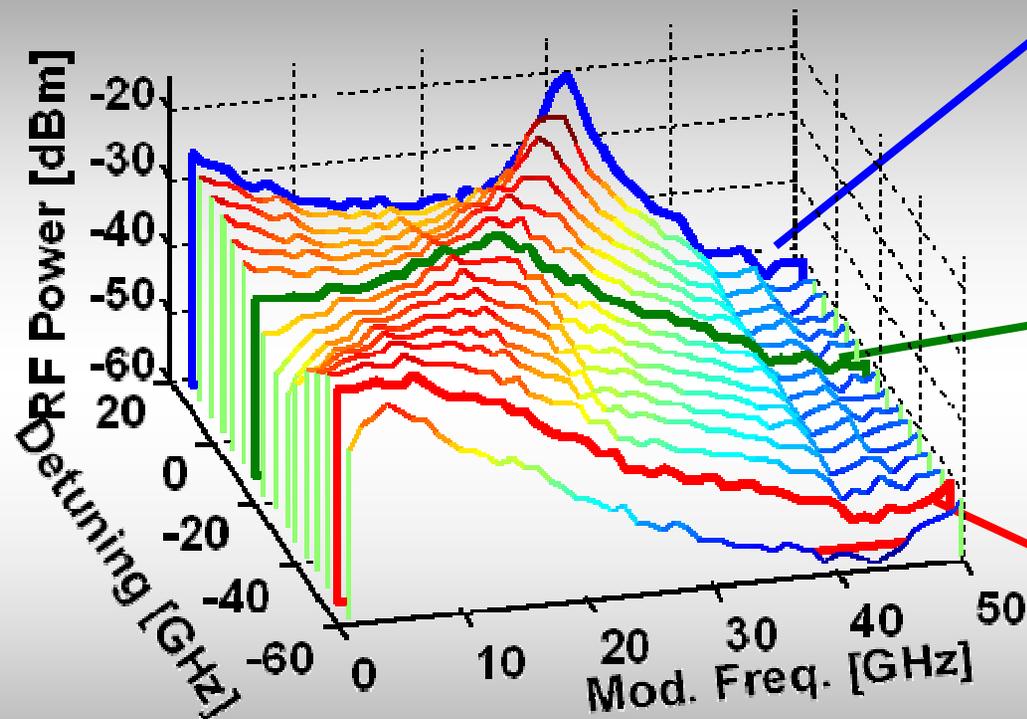




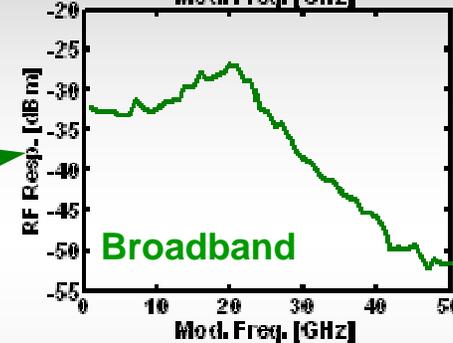
Frequency Response of Injection-Locked DFB Lasers



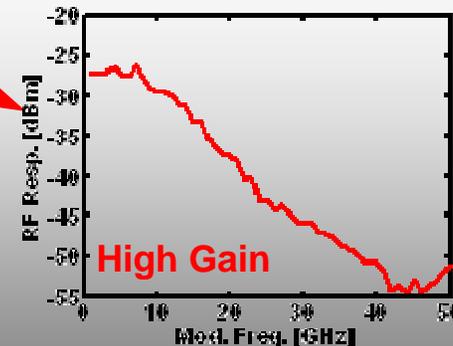
Electrical Frequency Response, $P_{\text{ratio}} = +8 \text{ dB}$



Large Positive Frequency Detuning

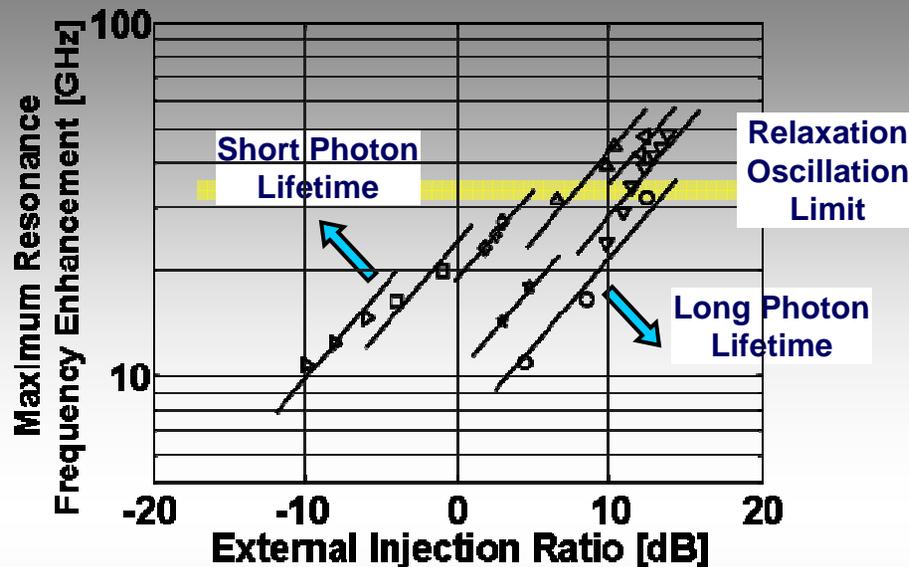


Small Positive Frequency Detuning

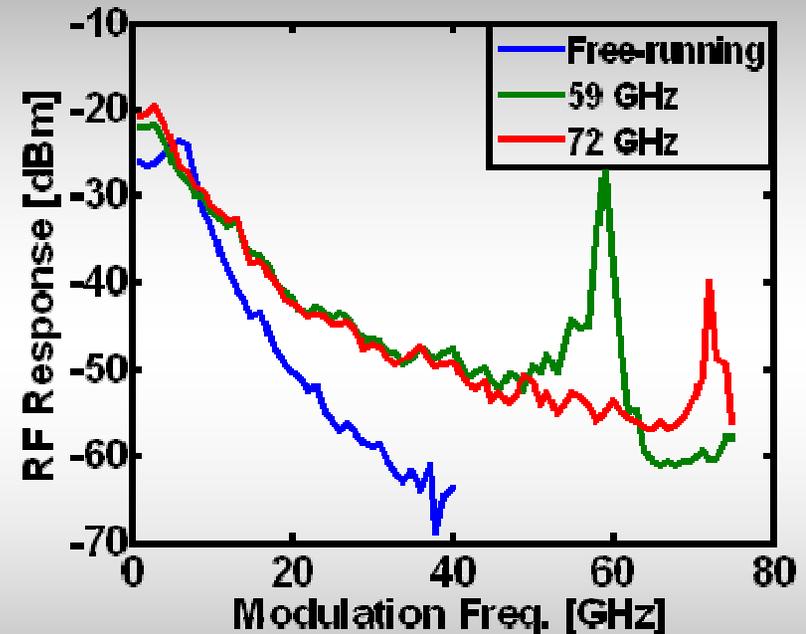


Negative Frequency Detuning

Profs. Wu and Chang-Hasnain
UC Berkeley



Ultra-high injection ratio and near positive detuning edge



Lau, Sung, and Wu, OFC 2006

- Strong injection locking can overcome the fundamental limit of relaxation oscillation
- Maximum enhanced resonance frequency under optical injection:

$$\tau_p \cdot f_{R,\max} = \frac{1}{4\pi} \sqrt{R_{\text{ext}}} \quad \begin{array}{l} \tau_p : \text{photon lifetime} \\ R_{\text{ext}} : \text{ext. injection ratio} \end{array}$$

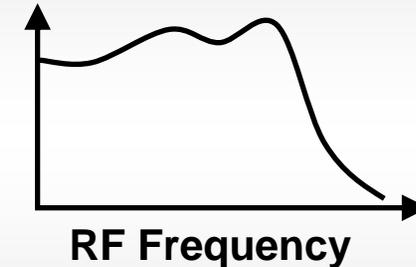
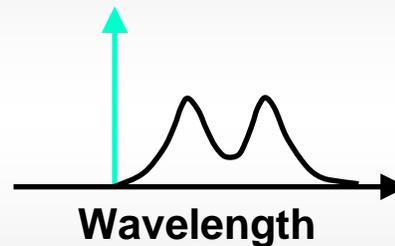
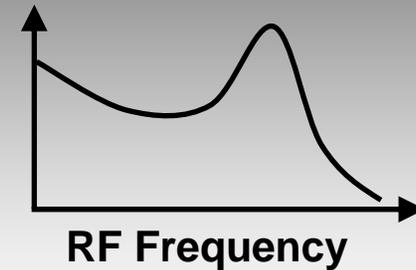
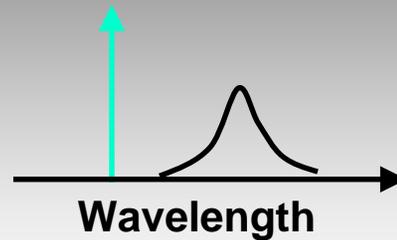
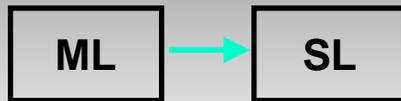
- This “time-bandwidth product” provides a guideline for device optimization



Optical Cavity Engineering For High Speed



- “Optical doublet” cavity



- Similar to high-order filter theory
 - “Chebyshev” cavity

How can this concept be implemented in an integrated structure?

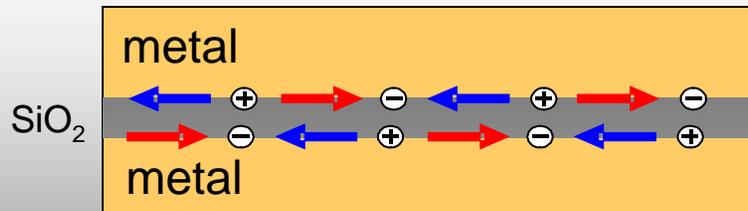
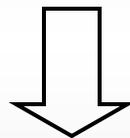
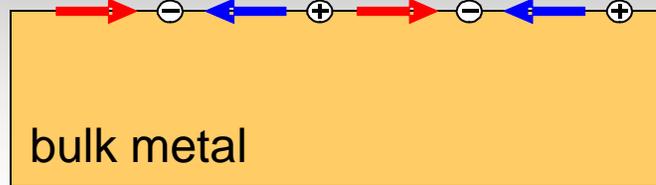


Sub- λ cavity with surface plasmons



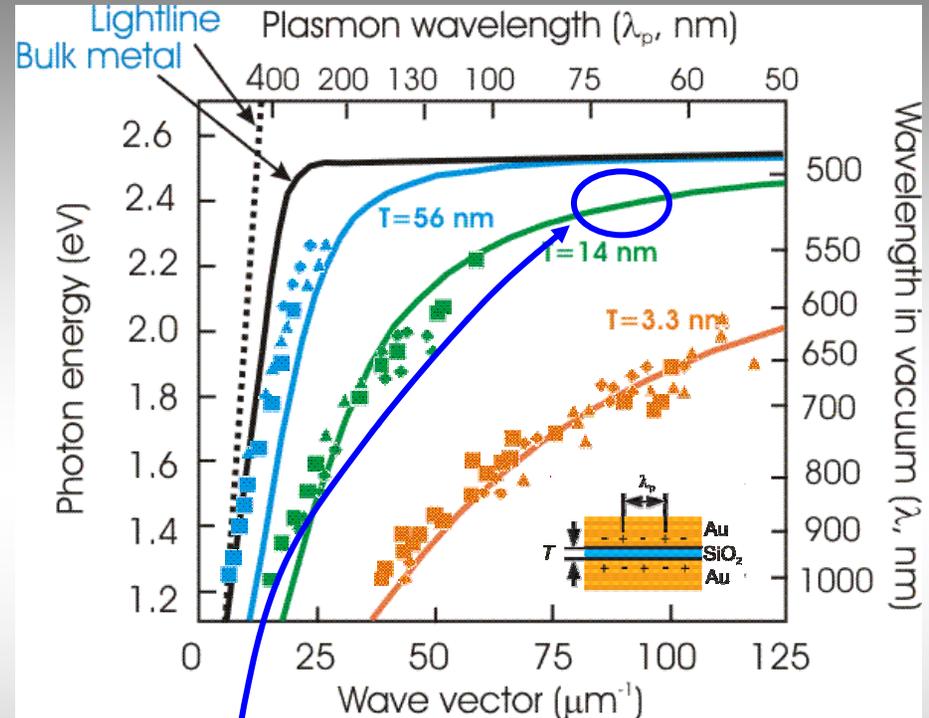
Miyazaki *et al*, Tsukuba (Japan), PRL 96, 097401 (2006)

Surface plasmons are longitudinal charge density fluctuations on the surface of a conductor



Plasmons confined to nm thick layers propagate through μm -length distances

Calculated dispersion relation



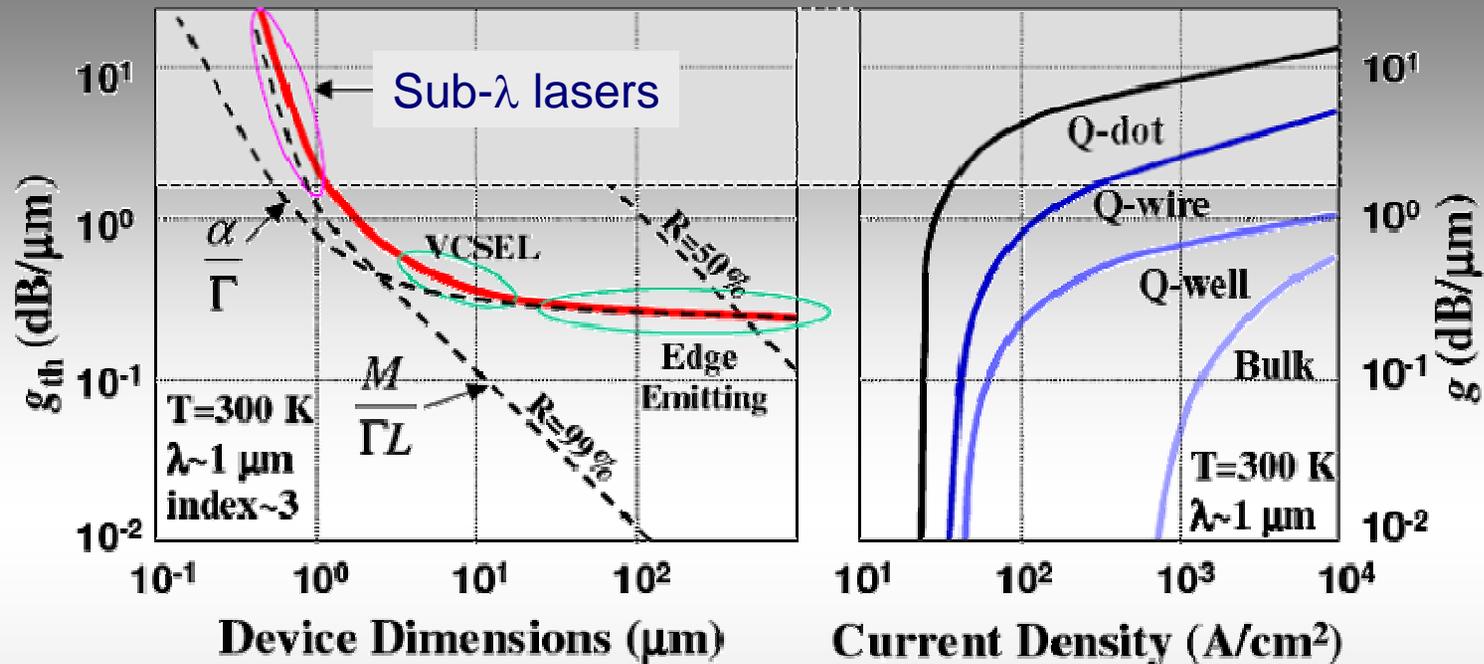
For visible free-space wavelength we get plasmons with soft x-ray wavelengths!

Visible light squeezed into a 3.3 nm core and its λ reduced by 92%, to $\lambda_p \sim 51\text{-}55\text{ nm}$.

BUT: unknown loss-confinement relationship!



What does it take to make a small laser?



$$g_{th} = \frac{1}{\Gamma} \left(\alpha + \frac{M}{L} \right)$$

M is the mirror loss (dB), Γ is the modal confinement factor, and L is the cavity length

$$R_{th} \sim \frac{1}{Q} \frac{V_c}{V_m} + (1 - \beta) \frac{N_{th} V_c}{\tau_r} + \frac{N_{th} V_c}{\tau_{nr}}$$

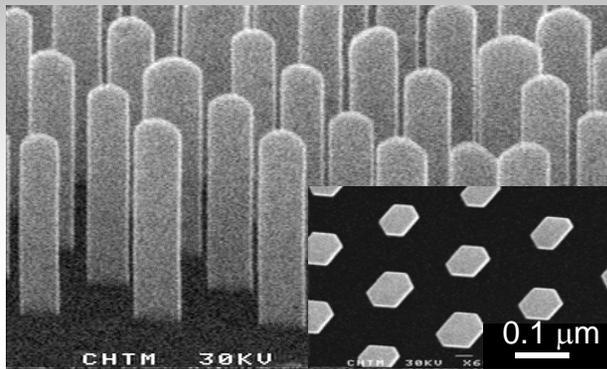


Need higher gain and new laser concepts

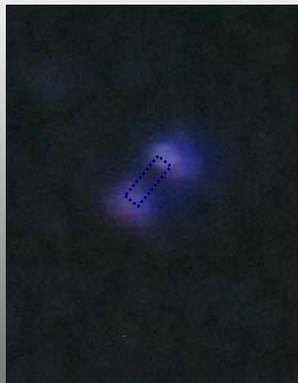
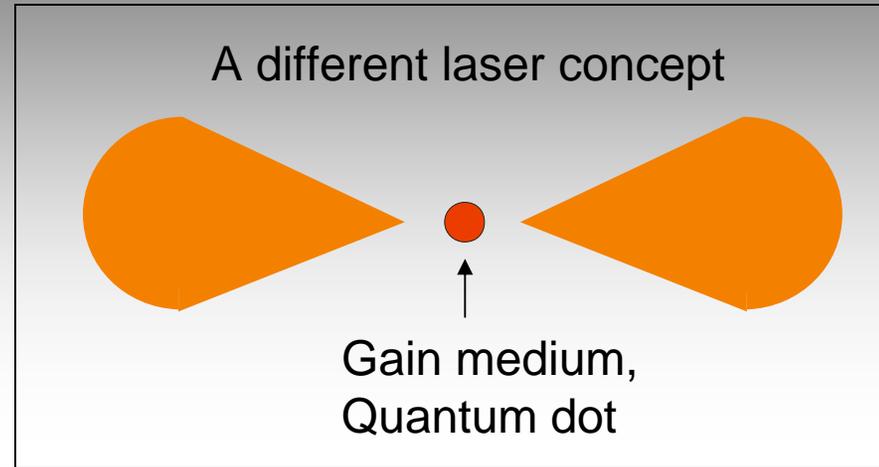


Lithographic placement and selective growth of GaN nanowires

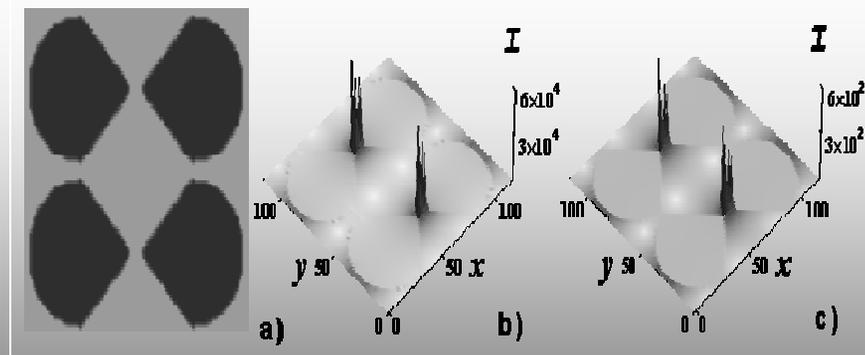
Defect-free structures for $d < 100$ nm!



UNM, Prof. Steve Brueck



Lasing GaN nanowire,
UNM and Sandia NL,
 $L = 5 \mu\text{m}$

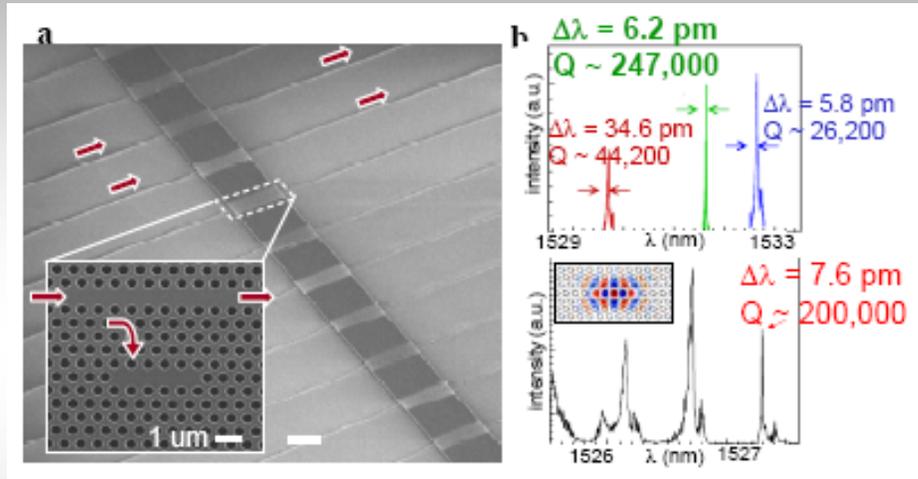




Young Faculty Award (YFA)



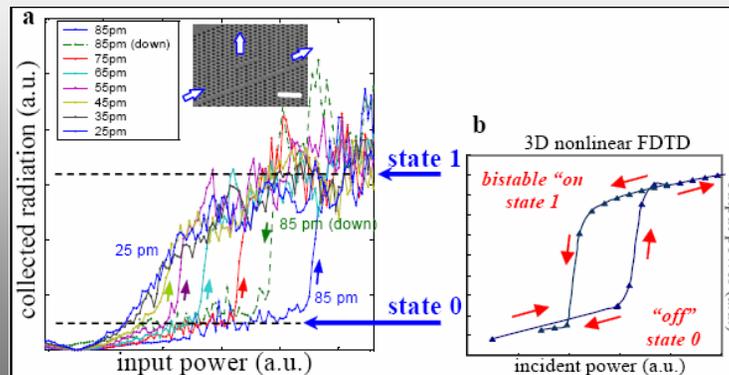
126 submissions from 72 Universities,
from Harvard College to Texas Woman's.
24 Awards at \$150,000 each



Prof. C.W. Wong, Columbia

Waveguide coupled photonic cavity devices with high $Q \sim 247,000$ and, at the same time, tightly confined mode with $V_m \sim (\lambda/n)^3$ have been obtained.

These Si-based structures show cavity-enhanced optical bistability at low input powers, ~ 1 mW, and thermal TPA-induced free-carrier dispersion. This result, attributed to suppression of radiative modes and excellent fabrication procedures, opens the possibility of $Q \sim 1 \times 10^6$.



- a) Cavity radiation against input power vs detuning. Bistable contrast increases with larger detuning but at a higher threshold.
- a) 3D nonlinear FDTD bistable simulation.

